



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Zhang et al.

Serial No.: 09/722,400

Filed: November 27, 2000

For: POLYIMIDE AS A MASK IN VAPOR
HYDROGEN FLUORIDE ETCHING

Confirmation No.: 5784

Examiner: C. Young

Group Art Unit: 1756

Attorney Docket No.: 2269-7144.2US
(95-0813.02/US)

Notice of Allowance Mailed:

May 26, 2006

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EV827472677US

Date of Deposit with USPS: August 22, 2006

Person making Deposit: Brett Hooke

OK
fo
Carter
Jung
al/104
Sir:

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Please amend the above-referenced application as follows:

Amendments to the specification begin on page 2 of this paper;

Amendments to the claims are set forth in the listing of the claims that begins on page 16 of this paper;

Remarks start at page 20 of this paper.